



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/054,697
Applicant: Walitzki et al.
Filed: January 18, 2002
TC/A.U.: 2822
Examiner Guerrero, M.

Confirmation No. 5401

#12/A
10/1/02

Docket No.: 4451-24-1 (formerly 020016-000311US)
Customer No.: 22442

For: "METHOD FOR FINISHING POLY-SILICON OR AMORPHOUS SUBSTRATE STRUCTURES"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

CERTIFICATE OF MAILING	
I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA VA 22313-1450 ON SEPTEMBER 15, 2003.	
SHERIDAN ROSS P.C.	
BY:	<u>D. I. H. H.</u>

AMENDMENT AND RESPONSE

Dear Sir:

Applicant submits this Amendment and Response to address the Office Action having a mailing date of March 13, 2003 (Paper No. 7). Enclosed herewith is a petition for a three-month extension of time, thereby extending the time period for response from June 13, 2003 to September 13, 2003, as well as a check in the amount of \$465.00 as the fee for such extension. Please credit any overpayment or charge any underpayment to Deposit Account No. 19-1970. Please credit any overpayment or charge any underpayment to Deposit Account No. 19-1970.

Amendments to the Claims are shown in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

Please amend the above-identified patent application as follows:

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